

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	594313	resistor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:43
L2	5923772	base substrate wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:25
L3	3658133	(semiconductor\$4 semi adj conduct\$4 silicon si ge germanium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:25
L4	295994	(silicid\$4 silicat\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:32
L5	5113615	overlap\$4 portion	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:33
L6	1287262	(dop\$4 impurit\$3 (ion near\$3 implant\$6) diffus\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:37
L7	9367152	high\$3 different	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:38
L8	539	(257/538).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/04/30 14:44
L9	125	8 and 4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/30 14:59

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L10	15954	1.clm.	US-PGPUB	OR	ON	2006/04/30 15:06
L11	279181	2.clm.	US-PGPUB	OR	ON	2006/04/30 15:06
L12	110497	3.clm.	US-PGPUB	OR	ON	2006/04/30 15:06
L13	11258	4.clm.	US-PGPUB	OR	ON	2006/04/30 15:07
L14	355330	5.clm.	US-PGPUB	OR	ON	2006/04/30 15:07
L15	47451	6.clm.	US-PGPUB	OR	ON	2006/04/30 15:08
L16	65	10 and 11 and 12 and 13 and 14 and 15	US-PGPUB	OR	ON	2006/04/30 15:09
L17	479	13 same 14 same 15	US-PGPUB	OR	ON	2006/04/30 15:09
L18	16	16 and 17	US-PGPUB	OR	ON	2006/04/30 15:09